

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: ) Group Art Unit: 2813  
Junichi SATO ) Examiner: Laura M. Schillinger  
)  
Application No.: 10/828,882 )  
Filed: April 21, 2004 )  
)  
For: SEMICONDUCTOR THIN FILM )  
AND METHOD OF FABRICATING )  
SEMICONDUCTOR THIN FILM, ) Confirmation No.: 5622  
APPARATUS FOR FABRICATING )  
SINGLE CRYSTAL SEMICONDUCTOR )  
THIN FILM, AND METHOD OF )  
FABRICATING SINGLE CRYSTAL THIN )  
FILM, SINGLE CRYSTAL THIN FILM )  
SUBSTRATE, AND SEMICONDUCTOR )  
DEVICE )

November 22, 2006

**FILED ELECTRONICALLY VIA EFS-WEB**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**  
**UNDER 37 C.F.R. § 1.111**

Dear Sir:

In response to the Office Action of August 23, 2006, Applicants request the Examiner consider the following amendments and remarks.